

Notice of References Cited

Application/Control No.

09/622,949

Applicant(s)/Patent Under
Reexamination
KAMEYAMA, TAKASHI

Examiner

Gevell Selby

Art Unit

2615

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,111,607	08-2000	Kameyama, Takashi	348/645
	B	US-5,555,031	09-1996	Van Rooij, Johannes H. J. M.	348/645
	C	US-5,296,920	03-1994	Sakaue et al.	348/675
	D	US-5,130,786	07-1992	Murata et al.	375/240.25
	E	US-5,949,482	09-1999	Kawa, Seiji	348/222.1
	F	US-6,515,700	02-2003	Nakamura et al.	348/645
	G	US-5,124,785	06-1992	Hirose et al.	348/649
	H	US-2003/0133019	07-2003	HIGURASHI et al.	348/222.1
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	EP0801509A2				
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.